Special Issue MFHS 2019

Message from the Guest Editor

This Special Issue will publish both selected papers from the 4th International Conference on Microfluidic Handling Systems (www.mfhs2019.org, 2–4 October, 2019, Enschede, The Netherlands) and external contributions. The conference focuses mainly on the technology, components, devices and systems that enable the application in microfluidic systems. We invite submission of papers on systems and devices for accurate handling (e.g., analysis, dosing, measurement and control) of (extremely) small mass flow rates of both gases and liquids, and corresponding measurement and control principles, including but not limited to:

- Thermal, ultrasonic, Coriolis and other principles for flow measurement
- Piezo-electric, electromagnetic, electrostatic and other principles for flow control
- Electronic instrumentation, closed loop control systems
- Innovative methods in calibration equipment and methodology
- Micro- and nanomachining, 3D printing and other fabrication technologies
- Device or wafer level characterization, packaging and testing
- Application proposals

Guest Editor

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Deadline for manuscript submissions

closed (31 March 2020)



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Message from the Editor-in-Chief

You are invited to contribute research articles or comprehensive reviews for consideration and publication in *Micromachines* (ISSN 2072-666X). *Micromachines* is published in the open access format. Research articles, reviews and other contents are released on the internet immediately after acceptance. The scientific community and the general public have unlimited free access to the content as soon as it is published. As an open access journal, *Micromachines* is supported by the authors or their institutes by payment of article processing charges (APC) for accepted papers. We are pleased to welcome you as our authors.

Editor-in-Chief

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